

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:

Kohlman Von-platen et al.

Application No: 10/541,819

Filed: February 10, 2006

For: **METHOD FOR THE PRODUCTION  
OF A SEMICONDUCTOR  
COMPONENT**

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Atty. Docket No: 31583-219318

Art Unit: 2894

Examiner: B. Smith

Confirmation No: 4273

Customer No: 26694

PATENT TRADEMARK OFFICE

**AMENDMENT AFTER FINAL AND REQUEST FOR RECONSIDERATION**

**MS AF**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Madam:

In response to the Office Action dated March 31, 2009, please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.